



Attorney Docket No. 5649-1055

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Re: Park et al.

Examiner: H. Jey Tsai

Serial No.: 10/615,362

Group Art Unit: 2812

Filed: July 8, 2003

Confirmation No.: 8781

For: METHODS FOR FORMING A METAL CONTACT IN A SEMICONDUCTOR
DEVICE IN WHICH AN OHMIC LAYER IS FORMED WHILE FORMING A
BARRIER METAL LAYER

Date: February 17, 2004

Mail Stop Non-Fee Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

**AMENDMENT AND RESPONSE TO
ELECTION REQUIREMENT**

Sir:

Applicants provide the present Amendment to address the issues raised in the Election Requirement mailed January 20, 2004. Applicants provide the present Amendment pursuant to the rules stated in revised 37 C.F.R. 1.121 that became effective on July 30, 2003.

Amendments to the Claims are reflected in the listing of claims, which begins on page 2 of this paper.

Remarks begin on page 4 of this paper.